
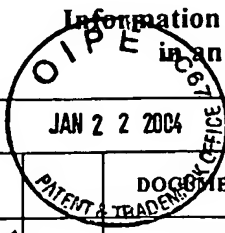
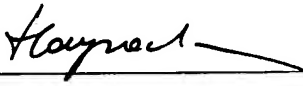


PTO-1449 Information Disclosure Citation in an Application			Application No. Unassigned Docket Number 064441.0263		Applicant(s) Pascal Huyghe et al. Group Art Unit Unknown Filing Date June 27, 2003		
U.S. PATENT DOCUMENTS							
		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	A.						
	B.						
	C.						
	D.						
	E.						
	F.						
	G.						
	H.						
	I.						
	J.						
	K.						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
	L.						
	M.						
	N.						
	O.						
	P.						
	Q.						
NON-PATENT DOCUMENTS							
		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)					DATE
MA	R.	Edward Suttile et al.'s "Streamlining the front-end reticle fabrication process by improving mask ordering" at internet address < http://www.micromagazine.com/archive/02/06/suttile.html > and published in June 2002 Issue of Micro Magazine. 10 Pages					June 2002
MA	S.	Brock Hotaling, "MaskPilot Revolutionizes Semiconductor Software," <u>Reticle and Mask Solutions</u> , Vol. I, No. 1, Fall 2002, 4 Pages					Fall 2002
	T.	Photronics, Inc., "Photronics eBeam Phase Masks: Tackling the Challenges of Special Lightwave Applications," <u>Reticle and Mask Solutions</u> , Vol. XIII, No. 1, Spring 2002, 4 Pages					Spring 2002
EXAMINER					DATE CONSIDERED		
					2/24/2006		
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							

PTO-1449		Application No. 10/607,944		Applicant(s) Pascal Huyghe et al.			
Information Disclosure Citation in an Application 		Docket Number 064441.0263		Group Art Unit 2122	Filing Date June 27, 2003		
		U.S. PATENT DOCUMENTS					
	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
MA A.	5909570	6/1/99	Webber	395	500	6/9/97	
MA B.	6012070	1/4/00	Cheng et al.	707	505	11/15/96	
MA C.	2002/0184266	12/5/02	Blessin	707	513	3/20/02	
D.							
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F.							
G.							
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I.							
J.							
K.							
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
MA L.	01/63446 A2 ✓	8/30/01	WO	G06F	17/00	X	
MA M.	02/03141 A2 ✓	1/10/02	WO	G03F	1/00	X	
N.							
O.							
P.							
Q.							
NON-PATENT DOCUMENTS							
	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)						DATE
MA R.	✓ PCT International Search Report application number PCT/US03/20345, 7 pages.						Mailing 12/19/03
S.							
T.							
EXAMINER 				DATE CONSIDERED 2/24/2006			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							